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APR 09 2004

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Notice of References Cited		Application/Control No. 09/830,380	Applicant(s)/Patent Under Reexamination ANDRE ET AL.	
Examiner Tamra L. Dicus		Art Unit 1774	Page 1 of 1	

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
✓ A	US-6,319,730	11-2001	Ramdani et al.	438/3
✓ B	US-6,077,569	06-2000	Knapp et al.	427/534
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
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FOREIGN PATENT DOCUMENTS

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N					
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NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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Wm. M.
Examiner

3/24/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional) BREV 13186	Application Number
Applicant(s) ANDRE et al	
Filing Date APRIL 25, 2001	Group Art Unit

EXAMINER INITIAL	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)
WA	"Optical Coatings Deposited by Reactive Ion Plating" by A.J. Waldorf et al Applied Optics/October 1, 1993/Vol. 32, No. 28 pgs. 5583-5593
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	"Stress and Environmental Shift Characteristics of HfO ₂ /Si ₂ Multilayer Coatings" by J.F. Anzellotti et al Proceedings Reprint/SPIE - The International Society for Optical Engineering Reprinted from 28th Annual Boulder Damage Symposiumproceedings "Laser-Induced Damage in Optical Materials: 1996" October 7-9, 1996, Boulder, Colorado SPIE Vol. 2966, pgs. 258-264
	"Study of the Structure and Properties of Thick Vacuum Condensates of Nickel, Titanium, Tungsten, Aluminum Oxide and Zirconium Dioxide" by B.A. Movchan et al F metal.metalloved., 28, No. 4, 653-660, 1969 pgs. 83-90
WA	"Nano Absorbing Centers: A Key Point in Laser Damage of Thin Films" by J. Dijon et al SPIE Vol. 2966, pgs 315-325
EXAMINER <i>WA</i>	DATE CONSIDERED <i>3-24-05</i>

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